



ATTENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Minoru KATAYAMA et al.

Application No.: 09/690,590

Filed: October 18, 2000

For: SURFACE TEXTURE MEASURING MACHINE,  
LEVELING DEVICE FOR SURFACE TEXTURE  
MEASURING MACHINE AND ORIENTATION-  
ADJUSTING METHOD OF WORKPIECE OF  
SURFACE TEXTURE MEASURING MACHINE

Group Art Unit: 2856

Examiner: M. Cygan

Docket No.: 107612

MAIL STOP RCE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s) continued examination and entry and consideration of the June 10, 2003 Amendment After Final Rejection submission. The above-identified application was filed on or after June 9, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 143886 in the amount of  \$750.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

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Richard J. Kim  
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JAO:RJK/mdw

Date: July 7, 2003

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